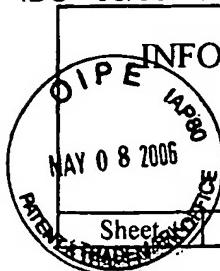


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**INFORMATION DISCLOSURE  
CITATION**  
PTO-1449

Sheet

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of

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**Complete If Known**

Application Number	10/825,795
Filing Date	April 13, 2004
First Named Inventor	Jun Li
Art Unit	3753
Examiner Name	Teresa J. Walberg
Attorney Docket Number	ARC-15173-1

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		Number - Kind Code <sup>1</sup>					
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		Country Code <sup>2</sup> - Number <sup>3</sup> - Kind Code <sup>4</sup> (if known)					Yes	No

**OTHER NON PATENT LITERATURE DOCUMENTS**

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<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>				<i>Complete If Known</i>			
Sheet	2	of	7	Application Number	10/825,795		
				Filing Date	April 13, 2004		
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				Art Unit	3753		
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				Attorney Docket Number	ARC-15173-I		

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				Examiner Name	Teresa J. Walberg		
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				Filing Date	April 13, 2004	
				First Named Inventor	Jun Li	
				Art Unit	3753	
				Examiner Name	Teresa J. Walberg	
				Attorney Docket Number	ARC-15173-1	

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		Country Code <sup>2</sup> - Number - Kind Code <sup>4</sup> (if known)					Yes	No
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Sheet	5	of	7	<b>Application Number</b> 10/825,795 <b>Filing Date</b> April 13, 2004 <b>First Named Inventor</b> Jun Li <b>Art Unit</b> 3753 <b>Examiner Name</b> Teresa J. Walberg <b>Attorney Docket Number</b> ARC-15173-1

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Sheet	6	of	7	Attorney Docket Number	
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INFORMATION DISCLOSURE CITATION				<i>Complete If Known</i>	
PTO-1449				Application Number	10/825,795
				Filing Date	April 13, 2004
				First Named Inventor	Jun Li
				Art Unit	3753
				Examiner Name	Teresa J. Walberg
Sheet	1	of	1	Attorney Docket Number	ARC-15173-1

FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Class	Subclass	Translation
		Country Code* - Number • Kind Code* (if known)					Ycs      No

OTHER NON PATENT LITERATURE DOCUMENTS		
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
TW		ZHANG, Y., et al., "Formation of Metal Nanowires on Suspended Single-Walled Carbon Nanotubes", Appl. Phys. Lett, Vol. 77(19), p 3015 (2000).

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